

Application No. 10/603,310  
Resp. Dated June 21, 2006  
Reply to Office Action of February 21, 2006

Docket No.: 20793/0204471-US0

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(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Rafael STORZ

Application No.: 10/603,310

Confirmation No.: 5265

Filed: June 11, 2003

Art Unit: 2881

For: METHOD FOR SETTING THE SYSTEM  
PARAMETERS OF A SCANNING  
MICROSCOPE

Examiner: Bui Pho, Pascal M.

**RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 21, 2006

Sir:

**INTRODUCTORY COMMENTS**

In response to the office action dated February 21, 2006 received in the above-identified application, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper